

# Slot Waveguide

# Introduction

Research in the field of photonic integrated circuits (PICs) is taking a boost, especially because of its compatibility with the existing CMOS fabrication techniques using materials such as silicon (Si) and silicon dioxide (SiO<sub>2</sub>). Doing extensive numerical simulations on the photonic component design before fabricating the final prototype essentially saves resources.

Optical waveguides are extensively used in PICs. They have the responsibility to transfer optical energy and signals from one optical component to another. Exhaustive research has been performed with a particular type of configuration of the optical waveguide where the high refractive index medium (core) is wrapped around by a low refractive index medium (cladding). The physics behind transferring the energy in such core/cladding configuration is simply based on total internal reflection (TIR). For more information about traditional optical waveguides, see for example Ref. 1.

However counterintuitive, research is also carried out where the optical energy is made to confine within the low refractive index slot placed bordering two high refractive index slabs as shown in the Figure 1. This is the slot waveguide configuration.

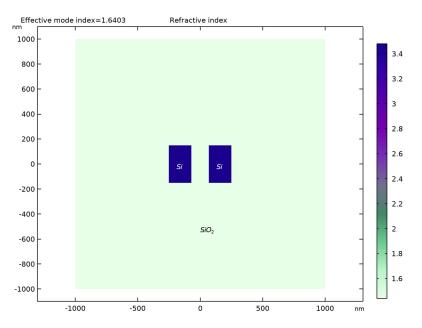


Figure 1: The slot waveguide geometry, also indicating the materials and their respective refractive indices.

Maxwell's equations state that the normal component of the electric displacement field (the D field) must be continuous across interfaces between materials with different refractive indices. Thus, the normal component of the electric field (E field) must be higher in the material with the low refractive index. This can be used to enhance and confine the guided mode into a narrow domain with low refractive index — the slot domain.

The dimension of this low refractive index domain is in orders of tens of nanometers which keeps the optical energy tightly confined to a narrow area giving a high optical energy density in the waveguide.

For more information about this slot waveguide structure, see Ref. 2.

# Model Definition

Mode analysis is performed on the cross section of the optical waveguide rather than modeling the complete 3D geometry.

The wave is propagating out of the plane in z direction, as shown below

$$E(x, y, z) = E(x, y)e^{J(\omega t - \beta z)}, \qquad (1)$$

where  $\omega$  is the angular frequency and  $\beta$  is the propagation constant.

The eigenvalue equation for the electric field is obtained from the Helmholtz equation

$$\nabla \times (\nabla \times E) - k_0^2 n^2 = 0 \tag{2}$$

The above equation is solved for the eigenvalue  $\lambda = -j\beta$ .

As shown in Figure 1, the silicon dioxide slot has a refractive index of 1.44, while the neighboring silicon slabs has a refractive index of 3.48.

After the mode analysis was performed, to optimize the width of the nano-slot to provide the maximum optical power through the waveguide, a parametric sweep of the width from 30 nm to 140 nm was performed.

To evaluate the normalized optical power and optical intensity through the waveguide, two integration operators were defined; first to perform an integration over the slot area and second for the complete waveguide area. A maximum operator was used to evaluate the normalized transverse electric field  $(E_x)$  through the center of the waveguide.

# Results and Discussion

The mode analysis evaluates the fundamental mode for a slot width of 50 nm at an operating wavelength of 1.55  $\mu$ m. The surface plot showcases the in-plane transverse electric field ( $E_x$ ) confined in the narrow slot as shown in the Figure 2.

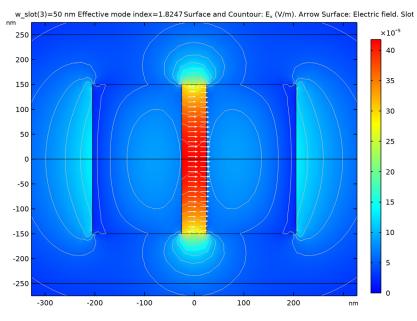


Figure 2: Schematic of the 50 nm width slot waveguide configuration with the transverse electric field  $(E_x)$  surface plot. The effective mode index is 1.8247.

The ratio of  $E_x$  over the absolute maximum of  $E_x$  was used to evaluate the normalized x component of the transverse electric field through the center of the waveguide, as shown in Figure 3. A large discontinuity in the electric field can be observed specifically at  $\pm 25$  nm.

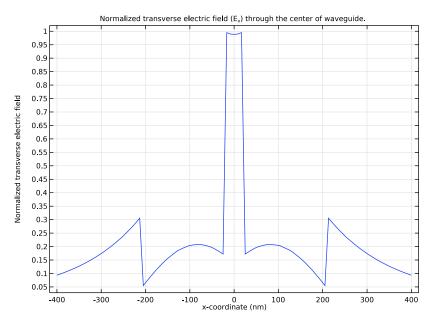


Figure 3: Normalized transverse electric field  $(E_x)$  through the center of the waveguide.

To visualize this discontinuity more comprehensively, a surface plot along with the height expression was plotted as shown in Figure 4.

w\_slot(3)=50 nm Effective mode index=1.8247 Surface: Electric field, x component (V/m)

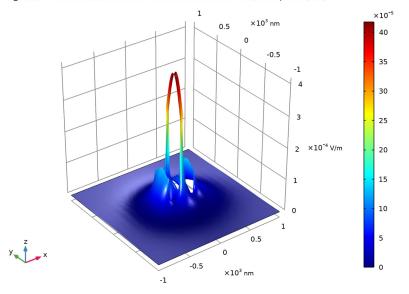


Figure 4: Surface plot along with its height expression to visualize a 3D representation of the transverse electric field  $E_x$ .

Finally, the normalized power and intensity through the waveguide with respect to the different slot width is highlighted in Figure 5. The normalized quantities were derived as the ratio of integrated optical power and optical intensity in the slot over the integrated optical power and optical intensity through the complete waveguide. It could be emphasized that the normalized optical power peaks for the slot width between 50 nm and 120 nm.

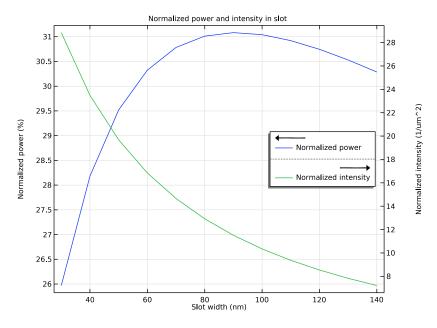


Figure 5: Normalized optical power and optical intensity through the slot with respect to the slot width for an operating wavelength of  $1.55 \,\mu m$ .

# References

1. B.E.A. Saleh and M.C. Teich, *Fundamentals of Photonics*, John Wiley & Sons, Inc., chap. 7, 1991.

2. V. Almeida, Q. Xu, C. Barrios, and M. Lipson, "Guiding and confining light in void nanostructure", *Optics Letters*, vol. 29, pp. 1209–1211, 2004.

Application Library path: Wave\_Optics\_Module/Waveguides\_and\_Couplers/
slot\_waveguide

# Modeling Instructions

From the File menu, choose New.

# NEW

In the New window, click 🙆 Model Wizard.

# MODEL WIZARD

- I In the Model Wizard window, click 🧐 2D.
- 2 In the Select Physics tree, select Optics>Wave Optics>Electromagnetic Waves, Frequency Domain (ewfd).
- 3 Click Add.
- 4 Click  $\bigcirc$  Study.
- 5 In the Select Study tree, select Preset Studies for Selected Physics Interfaces> Mode Analysis.
- 6 Click 🗹 Done.

## **GLOBAL DEFINITIONS**

## Parameters 1

Start by adding some parameters that will simplify the setup of the geometry, the materials, and the study.

I In the Model Builder window, under Global Definitions click Parameters I.

2 In the Settings window for Parameters, locate the Parameters section.

**3** In the table, enter the following settings:

Name	Expression	Value	Description
w_slab	180[nm]	I.8E-7 m	Width of slab
w_slot	50[nm]	5E-8 m	Width of slot
h_slot	300[nm]	3E-7 m	Height of slot
lda0	1.55[um]	1.55E-6 m	Operating wavelength
fO	c_const/lda0	1.9341E14 1/s	Operating frequency
n_slab	3.48	3.48	Refractive index of slab
n_slot	1.44	1.44	Refractive index of slot
n_clad	1.44	1.44	Refractive index of cladding
а	2[um]	2E-6 m	Exterior domain side length
b	800[nm]	8E-7 m	Interior domain width
с	500[nm]	5E-7 m	Interior domain height

#### GEOMETRY I

The geometry consists of a number of rectangles defining the slot, the slabs, and the cladding domain.

- I In the Model Builder window, under Component I (compl) click Geometry I.
- 2 In the Settings window for Geometry, locate the Units section.
- 3 From the Length unit list, choose nm.

# Rectangle 1 (r1)

- I In the Geometry toolbar, click 📃 Rectangle.
- 2 In the Settings window for Rectangle, locate the Size and Shape section.
- **3** In the **Width** text field, type w\_slot.
- 4 In the **Height** text field, type h\_slot.
- 5 Locate the Position section. From the Base list, choose Center.
- 6 Click 틤 Build Selected.

Rectangle 2 (r2)

- I In the Geometry toolbar, click 📃 Rectangle.
- 2 In the Settings window for Rectangle, locate the Size and Shape section.
- 3 In the Width text field, type w\_slab.
- 4 In the **Height** text field, type h\_slot.
- 5 Locate the **Position** section. In the **x** text field, type w\_slot/2.
- 6 In the y text field, type -h\_slot/2.
- 7 Click 틤 Build Selected.

Move I (movI)

- I In the Geometry toolbar, click 💭 Transforms and choose Move.
- 2 Select the object r2 only.
- 3 In the Settings window for Move, locate the Input section.
- 4 Select the Keep input objects check box.
- 5 Locate the **Displacement** section. In the x text field, type -w\_slot-w\_slab.
- 6 Click 틤 Build Selected.

## Rectangle 3 (r3)

- I In the **Geometry** toolbar, click **Rectangle**.
- 2 In the Settings window for Rectangle, locate the Size and Shape section.

- 3 In the Width text field, type a.
- 4 In the **Height** text field, type a.
- 5 Locate the Position section. From the Base list, choose Center.
- 6 Click 틤 Build Selected.
- 7 Click the + Zoom Extents button in the Graphics toolbar.

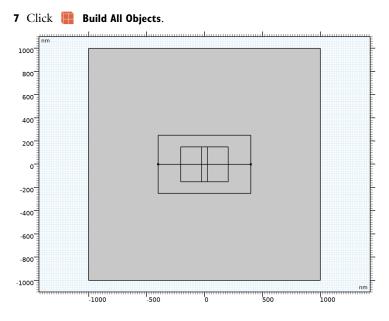
#### Rectangle 4 (r4)

- I In the **Geometry** toolbar, click **Rectangle**.
- 2 In the Settings window for Rectangle, locate the Size and Shape section.
- 3 In the Width text field, type b.
- 4 In the **Height** text field, type c.
- **5** Locate the **Position** section. From the **Base** list, choose **Center**.
- 6 Click 틤 Build Selected.

# Line Segment 1 (Is1)

Add a line segment to define a line through the center of the waveguide.

- I In the Geometry toolbar, click 🚧 More Primitives and choose Line Segment.
- 2 In the Settings window for Line Segment, locate the Starting Point section.
- **3** From the **Specify** list, choose **Coordinates**.
- 4 In the x text field, type -b/2.
- 5 Locate the Endpoint section. From the Specify list, choose Coordinates.
- 6 In the  $\mathbf{x}$  text field, type b/2.

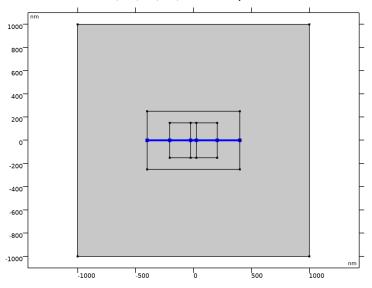


# DEFINITIONS

Now, add an operator taking the maximum value of a variable defined on the centerline through the waveguide.

Maximum I (Center)

- I In the Definitions toolbar, click *P* Nonlocal Couplings and choose Maximum.
- 2 In the Settings window for Maximum, type Maximum 1 (Center) in the Label text field.
- **3** Locate the **Source Selection** section. From the **Geometric entity level** list, choose **Boundary**.

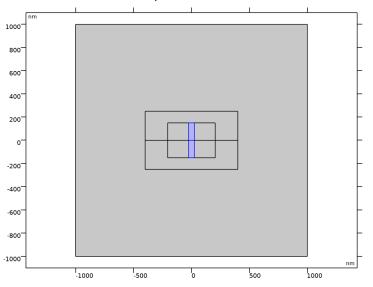


**4** Select Boundaries 7, 12, 17, 22, and 26 only.

Integration I (Slot)

- I In the **Definitions** toolbar, click *P* **Nonlocal Couplings** and choose **Integration**. This integration operator should be defined for the slot domain.
- 2 In the Settings window for Integration, type Integration 1 (Slot) in the Label text field.

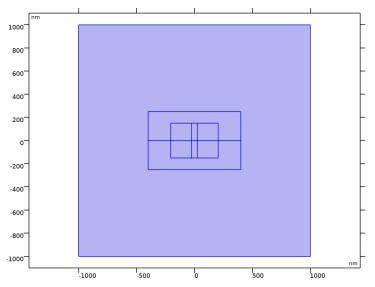
**3** Select Domains 6 and 7 only.



Integration 2 (Complete Waveguide)

I In the **Definitions** toolbar, click *N***onlocal Couplings** and choose **Integration**. This integration operator is defined for the whole waveguide structure.

2 Click in the Graphics window and then press Ctrl+A to select all domains.



**3** In the **Settings** window for **Integration**, type Integration 2 (Complete Waveguide) in the **Label** text field.

# MATERIALS

Now, define the materials in the waveguide structure.

Slot

- I In the Model Builder window, under Component I (compl) right-click Materials and choose Blank Material.
- 2 In the Settings window for Material, type Slot in the Label text field.
- 3 Locate the Material Contents section. In the table, enter the following settings:

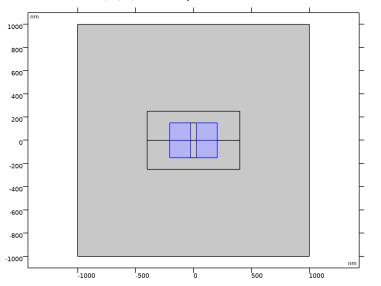
Property	Variable	Value	Unit	Property group
Refractive index, real part	n_iso ; nii = n_iso, nij = 0	n_slot	I	Refractive index
Refractive index, imaginary part	ki_iso ; kiii = ki_iso, kiij = 0	0	I	Refractive index

Slab

I Right-click Materials and choose Blank Material.

2 In the Settings window for Material, type Slab in the Label text field.

**3** Select Domains 4, 5, 8, and 9 only.



**4** Locate the **Material Contents** section. In the table, enter the following settings:

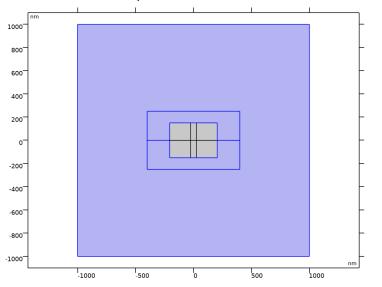
Property	Variable	Value	Unit	Property group
Refractive index, real part	n_iso ; nii = n_iso, nij = 0	n_slab	I	Refractive index
Refractive index, imaginary part	ki_iso ; kiii = ki_iso, kiij = 0	0	I	Refractive index

# Cladding

I Right-click Materials and choose Blank Material.

2 In the Settings window for Material, type Cladding in the Label text field.

#### **3** Select Domains 1–3 only.



**4** Locate the **Material Contents** section. In the table, enter the following settings:

Property	Variable	Value	Unit	Property group
Refractive index, real part	n_iso ; nii = n_iso, nij = 0	n_clad	I	Refractive index
Refractive index, imaginary part	ki_iso ; kiii = ki_iso, kiij = 0	0	I	Refractive index

# MESH I

Define a manual mesh sequence. The physics-controlled mesh sequence will be the starting point.

- I In the Model Builder window, under Component I (compl) click Mesh I.
- 2 In the Settings window for Mesh, locate the Mesh Settings section.
- 3 From the Sequence type list, choose User-controlled mesh.

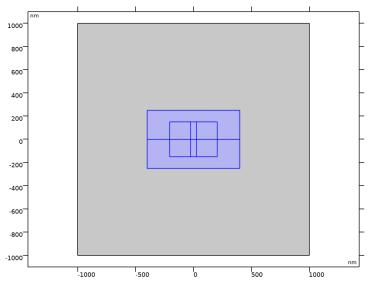
## Size

- I In the Model Builder window, under Component I (compl)>Mesh I click Size.
- 2 In the Settings window for Size, locate the Element Size section.
- **3** Click the **Predefined** button.

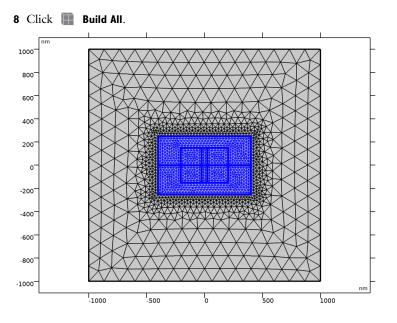
## Size I

This size node will set the maximum mesh element size for the center part of the waveguide structure to be one twentieth of its height.

- I In the Model Builder window, click Size I.
- 2 In the Settings window for Size, locate the Geometric Entity Selection section.
- 3 From the Geometric entity level list, choose Domain.
- **4** Select Domains 2–9 only.



- 5 Locate the Element Size section. Click the Custom button.
- 6 Locate the Element Size Parameters section. Select the Maximum element size check box.
- 7 In the associated text field, type c/20.



# STUDY I

Step 1: Mode Analysis

- I In the Model Builder window, under Study I click Step I: Mode Analysis.
- 2 In the Settings window for Mode Analysis, locate the Study Settings section.
- **3** In the **Mode analysis frequency** text field, type **f0**.
- 4 Select the Desired number of modes check box.
- 5 In the associated text field, type 2.
- 6 Select the Search for modes around check box.
- 7 In the associated text field, type n\_slab.

Add a parameteric sweep over the slot width.

Parametric Sweep

- I In the Study toolbar, click **Parametric Sweep**.
- 2 In the Settings window for Parametric Sweep, locate the Study Settings section.
- 3 Click + Add.

**4** In the table, enter the following settings:

Parameter name	Parameter value list	Parameter unit
w_slot (Width of slot)		m

- **5** Click to select row number 1 in the table.
- 6 Click Range.
- 7 In the Range dialog box, type 30[nm] in the Start text field.
- 8 In the Step text field, type 10[nm].
- 9 In the Stop text field, type 140[nm].
- IO Click Replace.

II In the Settings window for Parametric Sweep, locate the Study Settings section.

**12** In the table, enter the following settings:

Parameter name	Parameter value list	Parameter unit
w_slot (Width of slot)	range(30[nm],10[nm], 140[nm])	nm

**I3** In the **Study** toolbar, click **= Compute**.

## RESULTS

Electric Field (ewfd)

- I In the Settings window for 2D Plot Group, locate the Data section.
- 2 From the Parameter value (w\_slot (nm)) list, choose 50.

#### Surface 1

- I In the Model Builder window, expand the Electric Field (ewfd) node, then click Surface I.
- 2 In the Settings window for Surface, locate the Expression section.
- 3 In the **Expression** text field, type ewfd.Ex.

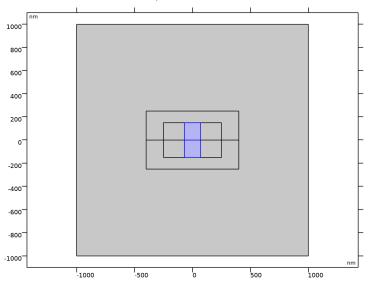
## Contour I

- I In the Model Builder window, right-click Electric Field (ewfd) and choose Contour.
- 2 In the Settings window for Contour, locate the Expression section.
- 3 In the **Expression** text field, type ewfd.Ex.
- 4 Locate the Coloring and Style section. From the Coloring list, choose Uniform.
- **5** From the **Color** list, choose **Gray**.
- 6 Clear the **Color legend** check box.

# Arrow Surface 1 Right-click Electric Field (ewfd) and choose Arrow Surface.

Selection I

- I In the Model Builder window, right-click Arrow Surface I and choose Selection.
- **2** Select Domains 6 and 7 only.



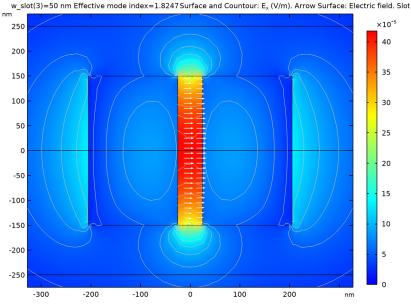
#### Arrow Surface 1

- I In the Model Builder window, click Arrow Surface I.
- 2 In the Settings window for Arrow Surface, click Replace Expression in the upper-right corner of the Expression section. From the menu, choose Component I (compl)> Electromagnetic Waves, Frequency Domain>Electric>ewfd.Ex,ewfd.Ey Electric field.
- **3** Locate the **Arrow Positioning** section. Find the **X grid points** subsection. In the **Points** text field, type **2**.
- 4 Find the Y grid points subsection. In the Points text field, type 30.
- 5 Locate the Coloring and Style section. Select the Scale factor check box.
- 6 In the associated text field, type 50000.
- 7 From the Color list, choose White.

#### Electric Field (ewfd)

- I In the Model Builder window, click Electric Field (ewfd).
- 2 In the Settings window for 2D Plot Group, click to expand the Title section.

- **3** From the **Title type** list, choose **Manual**.
- 4 In the Title text area, type Surface and Countour: E<sub>x</sub> (V/m). Arrow Surface: Electric field. Slot width: 50 nm.
- **5** Click the  $\bigoplus$  **Zoom In** button in the **Graphics** toolbar twice to see the electric field enhancement in the slot region and to verify that the main electric field component indeed is the *x* component.
- 6 In the Electric Field (ewfd) toolbar, click **O** Plot.

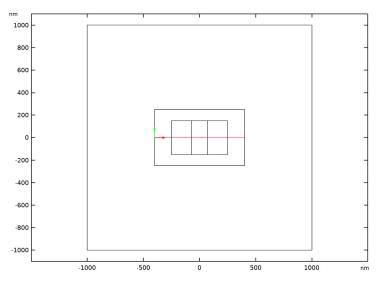


Add a Cut Line dataset for later use in a line graph.

Cut Line 2D I

- I In the Model Builder window, expand the Results>Datasets node.
- 2 Right-click **Datasets** and choose **Cut Line 2D**.
- 3 In the Settings window for Cut Line 2D, locate the Data section.
- 4 From the Dataset list, choose Study I/Parametric Solutions I (sol2).
- 5 Locate the Line Data section. In row Point I, set X to -b/2.
- 6 In row Point 2, set X to b/2.

7 Click 🗿 Plot.



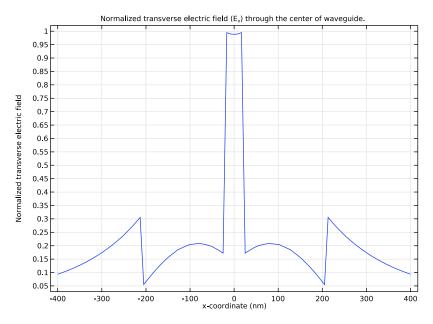
Normalized Transverse Electric Field

- I In the **Results** toolbar, click  $\sim$  **ID** Plot Group.
- 2 In the Settings window for ID Plot Group, type Normalized Transverse Electric Field in the Label text field.
- **3** Locate the **Data** section. From the **Dataset** list, choose **Cut Line 2D I**. Using the Cut Line dataset instead of a line selection will make the line appear as continuous also at points where the data actually is discontinuous.
- 4 From the Parameter selection (w\_slot) list, choose From list.
- 5 In the Parameter values (w\_slot (nm)) list, select 50.
- 6 From the Effective mode index selection list, choose First.
- 7 Click to expand the Title section. From the Title type list, choose Manual.
- 8 In the Title text area, type Normalized transverse electric field (E<sub>x</sub>) through the center of waveguide..
- 9 Locate the Plot Settings section. Select the y-axis label check box.
- **IO** In the associated text field, type Normalized transverse electric field.

Line Graph 1

- I Right-click Normalized Transverse Electric Field and choose Line Graph.
- 2 In the Settings window for Line Graph, locate the y-Axis Data section.

- **3** In the **Expression** text field, type ewfd.Ex/maxop1(ewfd.Ex).
- 4 Locate the x-Axis Data section. From the Parameter list, choose Expression.
- **5** In the **Expression** text field, type x.
- 6 In the Normalized Transverse Electric Field toolbar, click 💽 Plot.



# Transverse Electric Field

- I In the Home toolbar, click 🔎 Add Plot Group and choose 2D Plot Group.
- 2 In the Settings window for 2D Plot Group, type Transverse Electric Field in the Label text field.
- 3 Locate the Data section. From the Dataset list, choose Study I/ Parametric Solutions I (sol2).
- 4 From the Parameter value (w\_slot (nm)) list, choose 50.

#### Surface 1

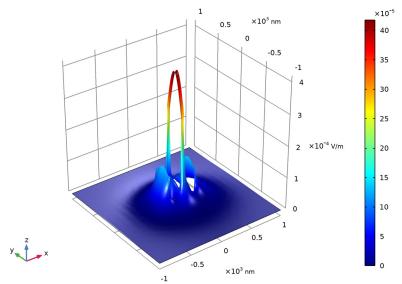
- I Right-click Transverse Electric Field and choose Surface.
- 2 In the Settings window for Surface, locate the Expression section.
- 3 In the **Expression** text field, type ewfd.Ex.

## Height Expression 1

Add a height expression node to more clearly visualize the electric field enhancement in the slot region.

#### Right-click Surface I and choose Height Expression.

w\_slot(3)=50 nm Effective mode index=1.8247 Surface: Electric field, x component (V/m)



#### Normalized Power and Intensity

Finally, add plots of the normalized power and intensity versus the slot width.

- I In the Home toolbar, click 📠 Add Plot Group and choose ID Plot Group.
- 2 In the Settings window for ID Plot Group, type Normalized Power and Intensity in the Label text field.
- 3 Locate the Data section. From the Dataset list, choose Study 1/ Parametric Solutions 1 (sol2).
- 4 From the Effective mode index selection list, choose First.
- 5 Locate the Title section. From the Title type list, choose Manual.
- 6 In the Title text area, type Normalized power and intensity in slot.
- 7 Locate the Plot Settings section. Select the Two y-axes check box.
- 8 Select the x-axis label check box.
- 9 In the associated text field, type Slot width (nm).

**IO** Select the **y-axis label** check box.

II In the associated text field, type Normalized power (%).

12 Select the Secondary y-axis label check box.

**I3** In the associated text field, type Normalized intensity (1/um<sup>2</sup>).

Global I

- I Right-click Normalized Power and Intensity and choose Global.
- 2 In the Settings window for Global, locate the y-Axis Data section.
- **3** In the table, enter the following settings:

Expression	Unit	Description
<pre>intop1(ewfd.Poavz)*100/intop2(ewfd.Poavz)</pre>	1	

- 4 Locate the x-Axis Data section. From the Axis source data list, choose Outer solutions.
- 5 From the **Parameter** list, choose **Expression**.
- **6** In the **Expression** text field, type w\_slot.
- 7 Click to expand the Legends section. From the Legends list, choose Manual.
- 8 In the table, enter the following settings:

#### Legends

Normalized power

Global 2

- I Right-click Global I and choose Duplicate.
- 2 In the Settings window for Global, locate the y-Axis Data section.
- **3** In the table, enter the following settings:

Expression	Unit	Description
intop1(ewfd.Poavz)/intop2(ewfd.Poavz)/	1/um^2	
(w_slot*h_slot)		

**4** Locate the **Legends** section. In the table, enter the following settings:

# Legends Normalized intensity

\_\_\_\_\_\_

Normalized Power and Intensity

I In the Model Builder window, click Normalized Power and Intensity.

2 In the Settings window for ID Plot Group, locate the Plot Settings section.

- 3 In the table, select the Plot on secondary y-axis check box for Global 2.
- **4** Locate the **Legend** section. From the **Position** list, choose **Middle right**, to make the legend panel not cover any of the line plots.
- 5 In the Normalized Power and Intensity toolbar, click **O** Plot.

